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Substitute for Form 1449 A & B/PTO				Application Number	National Stage of PCT/JP2005/006534
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Confirmation Number	Unknown
(use as many sheets as necessary)				Filing Date	September 28, 2006
				First Named Inventor	Takashi UDAGAWA
				Art Unit	Unknown
				Examiner Name	
Sheet	1	of	2	Attorney Docket Number	Q80899

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US 2001/0012678	A1	08/09/2001	SATORU TANAKA, ET AL
		US 5,228,044	A	07/13/1993	YASUO OHBA
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Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)		
		JP	2004-47847	A	SHOWA DENKO K.K.	Abstract
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		WO	02/097861	A2	SHOWA DENKO K.K.	
		JP	4-84486	A		Abstract
		JP	55-3834	B2		Abstract

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
		T. L. CHU, ET AL, "CRYSTAL AND EPITAXIAL LAYERS OF BORON PHOSPHIDE", JOURNAL OF APPLIED PHYSICS, VOL. 42, NO. 1, January 1991, PAGES 420-424	
		IWAO TERAMOTO, "INTRODUCTION OF SEMICONDUCTOR DEVICE", BAIHUKAN, March 30, 1995, PAGE 28	
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Examiner Signature	/Kevin Quinto/	Date Considered	03/31/2008
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 2 of 2

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		Y. KUMASIRO, ET AL, "PREPARATION AND ELECTRICAL PROPERTIES OF BORON AND BORON PHOSPHIDE FILMS OBTAINED BY GAS SOURCE MOLECULAR BEAM DEPOSITION", JOURNAL OF SOLID STATE CHEMISTRY, VOL. 133, 1997, PAGES 269-272	
		YUKINOBU KUMASHIRO, "ELECTRIC REFRACTORY MATERIALS", (USA), MARCEL DEKKER INC., 2000, PAGES 409-411	

Examiner Signature	/Kevin Quinto/	Date Considered	03/31/2008
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